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CONFIRMATION NO. 7222

SERIAL NUMBER 10/549,901	FILING or 371(c) DATE 09/20/2005 RULE	CLASS 428	GROUP ART UNIT 1795	ATTORNEY DOCKET NO. Q90414	
APPLICANTS Hiroyuki Akagawa, Tokyo, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/03617 03/18/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-077005 03/20/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/24/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /STEWART A FRASER/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 3	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
ADDRESS SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES					
TITLE Substrate for reticle and method of manufacturing the substrate, and mask blank and method of manufacturing the mask blank					
FILING FEE RECEIVED 1360	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		